Docket No. 0756-958

UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:)	
Shunpei YAMAZAKI et al.)	Examiner: S. Crane
Serial No. 08/183,800	·)	Art Unit: 2508
Filed: January 21, 1994	.)	
For: SEMICONDUCTOR MATERIAL)	
AND METHOD FOR FORMING)	
THE SAME AND THIN FILM)	
TRANSISTOR)	June 26, 1998

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on June 26, 1998.

AMENDMENT

Honorable Assistant Commissioner for Patents

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Sir:

In response to the Office Action mailed February 18, amend the above-identified application as follows.

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Washington, D.C. 20231

